



RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2125

00862.022199.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Keiji EMOTO ) : Examiner: P. L. Rodriguez  
Application No.: 09/833,766 ) : Group Art Unit: 2125  
Filed: April 13, 2001 ) : Confirmation No.: 4154  
For: PIPE STRUCTURE, ALIGNMENT APPARATUS,) April 2, 2004  
ELECTRON BEAM LITHOGRAPHY :  
APPARATUS, EXPOSURE APPARATUS, )  
EXPOSURE APPARATUS MAINTENANCE :  
METHOD, SEMICONDUCTOR DEVICE )  
MANUFACTURING METHOD, AND SEMI- :  
CONDUCTOR MANUFACTURING FACTORY )

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APR 07 2004

Technology Center 2100

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

LETTER TRANSMITTING CORRECTED FORMAL DRAWING


Sir:

Transmitted herewith is one (1) formal drawing sheet, Figure 12, to be substituted for the corresponding drawing sheet currently on file in the above-identified application.

Figure 12 incorporates the change requested by Applicants in a Request for Approval of Drawing Changes filed on November 19, 2003, which was subsequently approved by the Examiner in the Official Action dated February 5, 2004.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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Attorney for Applicant

Lawrence A. Stahl

Registration No. 30,110

FITZPATRICK, CELLA, HARPER & SCINTO  
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New York, New York 10112-3801  
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Keiji EMOTO

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For: PIPE STRUCTURE, ALIGNMENT APPARATUS, ELECTRON  
BEAM LITHOGRAPHY APPARATUS, EXPOSURE APPARATUS,  
EXPOSURE APPARATUS MAINTENANCE METHOD, AND  
SEMICONDUCTOR DEVICE MANUFACTURING METHOD, AND  
SEMICONDUCTOR MANUFACTURING FACTORY

)  
: Examiner: P. L. Rodriguez  
)  
: Group Art Unit: 2125  
)  
: Confirmation No.: 4154  
)  
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Sir:

Transmitted herewith is an Amendment After Final Rejection in the above-identified application.


☒ No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	27	MINUS	27	= 0	x \$9 \$18	\$0.00
INDEP. CLAIMS	11	MINUS	11	= 0	x \$43 \$86	\$0.00
Fee for Multiple Dependent claims \$145/\$290						—
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$0.00

- ☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.
- ☐ A check in the amount of \$\_\_\_\_\_ is enclosed including the additional claims fee.
- ☐ Charge \$\_\_\_\_ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
- ☐ A check in the amount of \$\_\_\_\_\_ to cover the fee for a two month extension is enclosed.
- ☐ A check in the amount of \$\_\_\_\_\_ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.

Respectfully submitted,



\_\_\_\_\_  
Attorney for Applicant  
Lawrence A. Stahl  
Registration No. 30,110

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